



AF / CFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto KOBAYASHI et al.

Group Art Unit: 3723

Application No.: 09/830,434

Examiner: H. Shakeri

Filed: April 26, 2001

Docket No.: 109352

For: POLISHING PAD AND POLISHING METHOD FOR SEMICONDUCTOR WAFER

STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the Board expects to take the appeal up for action.

Respectfully submitted,

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Date: April 19, 2005

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